



SN 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan Examiner: Sylvia MacArthur  
Serial No.: 09/652,713 Group Art Unit: 1763  
Filed: August 31, 2000 Docket: 303.928US5  
Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER  
PROCESSING

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COMMUNICATION CONCERNING RELATED APPLICATION(S)

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicant would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
08/618072	February 27, 1996	303.928US1	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING
08/910499	August 4, 1997	303.928US2	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING
08/944135 5952050	October 6, 1997	303.928US3	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING
09/133989	August 14, 1998	303.928US4	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING
09/652969 6793764	August 31, 2000	303.928US6	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request

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that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

TRUNG T. DOAN

By Applicant's Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

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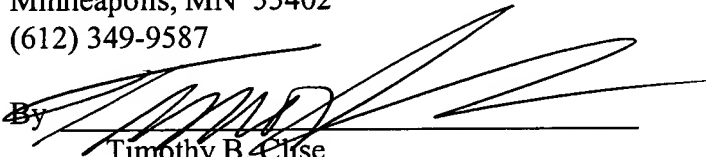
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Date

17 Jan '06

By



Timothy B. Clise

Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17 day of January, 2006.

Name

KATE GANNON

Signature





**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*IFW \$1763*

Applicant: **Trung T. Doan**

Title: **CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING**

Docket No.: 303.928US5  
Filed: August 31, 2000  
Examiner: Sylvia MacArthur

Serial No.: 09/652,713  
Due Date: January 19, 2006  
Group Art Unit: 1763

**MS Amendment**


Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ Return postcard.
- ☒ Amendment and Response (6 pgs.).
- ☒ Petition for Extension of Time (1 pg.)
- ☒ Check in the amount of \$450.00 to cover the Extension of Time Fee.
- ☒ Communication Concerning Related Applications (2 pgs.).
- ☒ Supplemental Information Disclosure Statement (2 pgs.), Form 1449 (1 pg.), and copies of 2 cited documents.
- ☒ Check in the amount of \$180.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
Customer Number 21186

By:   
Atty: Timothy B. Clise  
Reg. No. 40,957

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KATE GANNON  
Name

Kate G  
Signature

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(GENERAL)